



Sheet 1 of 1

Subst. Form PTO-1449				Docket Number (Optional) <b>SAM-0224DIV</b>		Application Number <b>10/690,105</b>		
INFORMATION DISCLOSURE CITATION IN AN APPLICATION  (Use several sheets if necessary)				Applicant <b>Won Song, et al.</b>				
				Filing Date <b>October 21, 2003</b>		Group Art Unit <b>3723</b>		
U. S. Patent Documents								
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<i>SK</i>	AA	6,285,455	9/4/01	Shiraishi	356	486	5/19/00	
<i>SK</i>	AB	6,255,189	7/3/01	Muller, et al.	438	401	10/19/99	
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	
<i>SK</i>	AL	2000- 0047405	8-17-00	Korea				X
	AM							
	AN							
	AO							
	AP							
	AQ							
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
<i>SK</i>	AR	Silicon Processing for the VLSI Era, Volume I: Process Technology, published in 1986 by Lattice Press of Sunset Beach, California, pages 459-473						
	AS							
	AT							
EXAMINER <i>Shonmaga</i>				DATE CONSIDERED <i>2/8/04</i>				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.								